



Atty. Dkt. No. 039262-0153

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Tadahiro OHMI et al.  
Title: SHOWER PLATE, PLASMA PROCESSING APPARATUS,  
AND PRODUCT MANUFACTURING METHOD  
Appl. No.: 10/584,340  
International Filing Date: 9/24/2004  
371(c) Date: 8/2/2006  
Examiner: Keath T. Chen  
Art Unit: 1792  
Confirmation Number: 2005

**AMENDMENT ACCOMPANYING RCE**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Final Office Action dated January 14, 2009 and Advisory Action dated July 22, 2009, concerning the above-referenced patent application. This communication is being filed concurrently with a Request for continued Examination (RCE).

Applicant has included payment for an one-month extension of time to make this response timely.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 6 of this document.

Please amend the application as follows: